

862.C2246



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Kazunori IWAMOTO, et al.) Examiner: Unassigned
Appln. No.: 09/866,600) Group Art Unit: 2812
Filed: May 30, 2001)
For: STAGE APPARATUS WHICH) September 27, 2001
SUPPORTS INTERFEROMETER,)
STAGE POSITION MEASUREMENT)
METHOD, PROJECTION EXPOSURE)
APPARATUS, PROJECTION)
EXPOSURE APPARATUS)
MAINTENANCE METHOD,)
SEMICONDUCTOR DEVICE)
MANUFACTURING METHOD, AND)
SEMICONDUCTOR MANUFACTURING:)
FACTORY)

Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

FEE STATEMENT

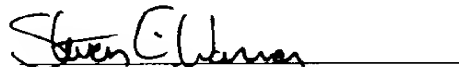
No fee or statement is required in connection with this Information Disclosure statement, since it is being submitted prior to the last of (1) issuance of a first official action on the merits or (2) expiration of the three month period following filing of the above-captioned application.

REMARKS

Applicants request that the cited information be considered by the Examiner and that an annotated copy of the enclosed Form PTO-1449 be returned with the next official communication indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants
Steven E. Warner
Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

SEW:cmv